

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**
(Not for submission under 37 CFR 1.99)

Application Number	10784903
Filing Date	2004-02-20
First Named Inventor	Issaq et al.
Art Unit	2811
Examiner Name	Nadav, Ori
Attorney Docket Number	ACT-390

U.S. PATENTS						Remove
Examiner Initial*	Cite No	Patent Number	Kind Code ¹	Issue Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear
ON	1	4599705	A	1986-07-08	Holmberg et al.	
	2	5008855	A	1991-04-16	Eltoukhy et al.	
	3	5126282	A	1992-06-30	Chiang et al.	
	4	5807786	A	1998-02-15	Chang	
	5	5965270	A	1999-10-12	Fang et al.	
	6	6107165	A	2000-08-22	Jain et al.	
	7	6124193	A	2000-09-26	Hawley et al.	
ON	8	6130572	A	2000-10-10	Ghilardelli et al.	

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**
(Not for submission under 37 CFR 1.99)

Application Number	10784903
Filing Date	2004-02-20
First Named Inventor	Issaq et al.
Art Unit	2811
Examiner Name	Nadav, Ori
Attorney Docket Number	ACT-390

ON	9	6259130	B1	2001-07-10	Wu	
	10	6316346	B1	2001-11-13	Gangopadhyay	
	11	6529038	B2	2003-03-04	Lambertson	
	12	6728126	B1	2004-04-27	Issaq et al.	
	13	6767769	B2	2004-07-27	Hawley et al.	
ON	14	6630396	B2	2003-10-07	Yang et al.	

If you wish to add additional U.S. Patent citation information please click the Add button.

Add

U.S.PATENT APPLICATION PUBLICATIONS

Remove

Examiner Initial*	Cite No	Publication Number	Kind Code*	Publication Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear
ON	1	20030062596	A1	2003-04-03	Hawley et al.	
ON	2	20030205723	A1	2003-11-06	Hawley et al.	

If you wish to add additional U.S. Published Application citation information please click the Add button.

Add

FOREIGN PATENT DOCUMENTS

Remove

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**
(Not for submission under 37 CFR 1.99)

Application Number		10784903
Filing Date		2004-02-20
First Named Inventor	Issaq et al.	
Art Unit	2811	
Examiner Name	Nadav, Ori	
Attorney Docket Number	ACT-390	

Examiner Initial*	Cite No	Foreign Document Number ³	Country Code ² i	Kind Code ⁴	Publication Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear	T ⁵
ON	1	2003030217	WO	A2	2003-04-10	Actel Corporation		<input type="checkbox"/>
	2	2003030217	WO	A3	2003-04-10	Actel Corporation		<input type="checkbox"/>
	3	2005081976	WO	A3	2005-09-09	Actel Corporatoin		<input type="checkbox"/>
	4	1305454	GB	A	1973-01-31	Schunk & Ebe GMBH		<input type="checkbox"/>
	5	1461824	EP	A2	2004-09-29	Actel Corporation		<input type="checkbox"/>
ON	6	1721338	EP	A2	2006-11-15	Actel Corporation		<input type="checkbox"/>

If you wish to add additional Foreign Patent Document citation information please click the Add button

NON-PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, pages(s), volume-issue number(s), publisher, city and/or country where published.	T ⁵
ON	1	Co-pending United States Patent Application No. 11/078,952 filed March 10, 2005 entitled SWITCHING RATIO AND ON-STATE RESISTANCE OF AN ANTIFUSE PROGRAMMED BELOW 5 mA AND HAVING A Ta or TaN BARRIER METAL LAYER.	<input type="checkbox"/>
ON	2	Co-pending United States Patent Application No. 10/625,490 filed July 22, 2003 entitled IMPROVING THE SWITCHING RATIO AND ON-STATE RESISTANCE OF AN ANTIFUSE PROGRAMMED BELOW 5 mA AND HAVING A Ta or TaN BARRIER METAL LAYER.	<input type="checkbox"/>

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**
(Not for submission under 37 CFR 1.99)

Application Number	10784903
Filing Date	2004-02-20
First Named Inventor	Issaq et al.
Art Unit	2811
Examiner Name	Nadav, Ori
Attorney Docket Number	ACT-390

ON	3	Co-pending United States Patent Application No. 11/195,002 filed August 1, 2005 entitled REPROGRAMMABLE METAL-TO-METAL ANTIFUSE EMPLOYING CARBON-CONTAINING ANTIFUSE MATERIAL.	<input type="checkbox"/>
ON	4	Co-pending United States Patent Application No. 11/210,492 filed August 23, 2005 entitled AMORPHOUS CARBON METAL-TO-METAL ANTIFUSE WITH ADHESION PROMOTING LAYERS.	<input type="checkbox"/>
ON	5	European Supplementary Search Report issued December 4, 2006 in European Patent Application No. 02776069.3, based on International Patent Application No. PCT/US02/31253 of co-pending United States Patent Application No. 09/972,825.	<input type="checkbox"/>

If you wish to add additional non-patent literature document citation information please click the Add button

EXAMINER SIGNATURE

Examiner Signature	ON	Date Considered	1/3/08
--------------------	----	-----------------	--------

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through a citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ See Kind Codes of USPTO Patent Documents at www.USPTO.GOV or MPEP 901.04. ² Enter office that issued the document, by the two-letter code (WIPO Standard ST.3). ³ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁴ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁵ Applicant is to place a check mark here if English language translation is attached.